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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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In re application of: PRITCHARD et al.

Attorney Docket No.:

03-2051/LSIIP240

Application No.: 10/791,337

Examiner: TRINH, Michael M.

Filed: March 1, 2004

Group: 2822

Title: SPACER-LESS TRANSISTOR  
INTEGRATION SCHEME FOR HIGH-K GATE  
DIELECTRICS AND SMALL GATE-TO-GATE  
SPACES APPLICABLE TO Si, SiGe STRAINED  
SILICON SCHEMES

Confirmation No.: 2401

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**CERTIFICATE OF EFS-WEB TRANSMISSION**

I hereby certify that this correspondence is being transmitted electronically through EFS-WEB to the Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450 on **October 17, 2007**.

Signed: \_\_\_\_\_ /Lydie Fitzsimmons/  
Lydie Fitzsimmons

**AMENDMENT D**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated August 27, 2007, please amend the above-identified patent application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begin on page 2 of this paper.

**Remarks/Arguments** begin on page 5 of this paper.